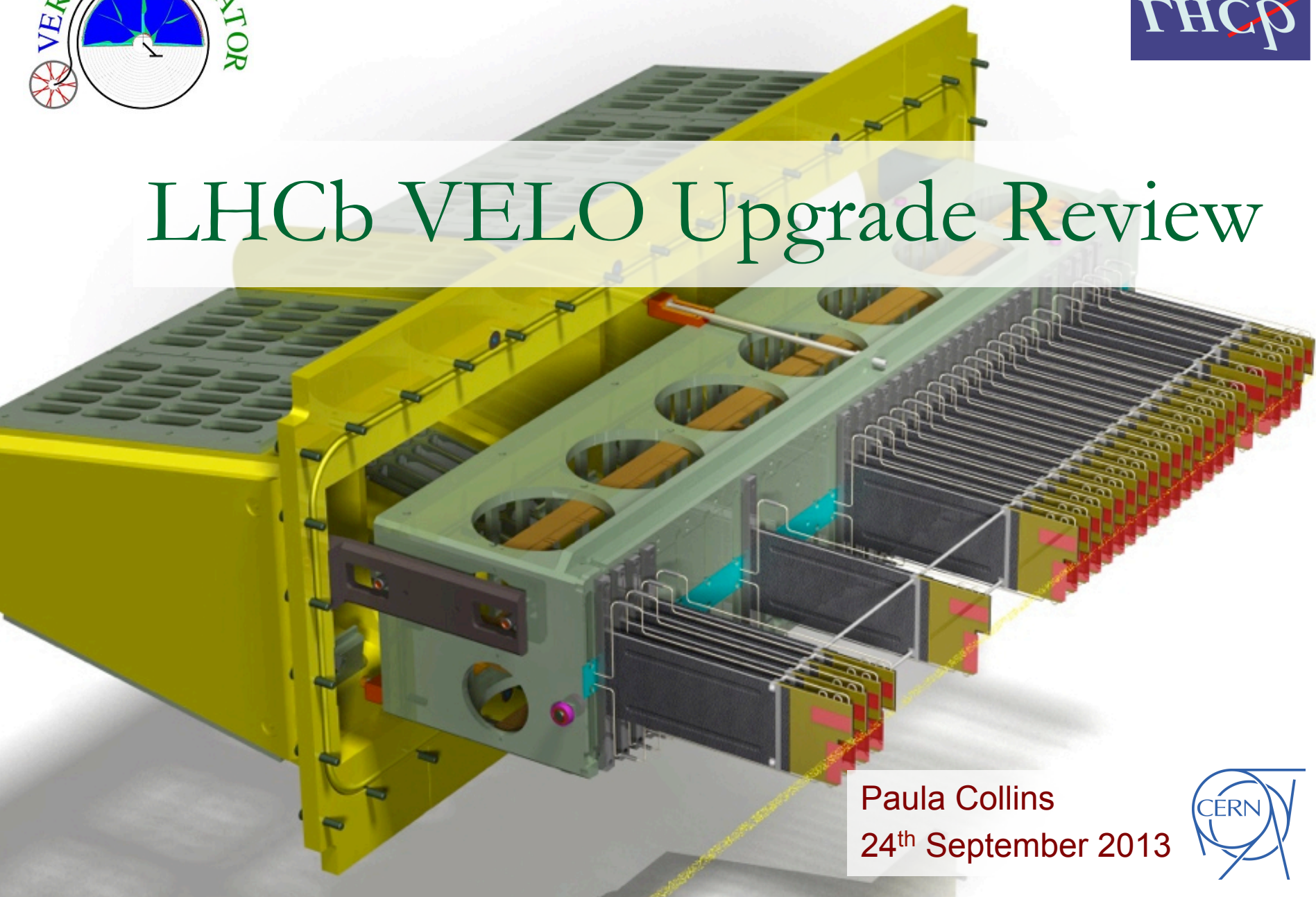




# LHCb VELO Upgrade Review



Paula Collins  
24<sup>th</sup> September 2013



# Introduction & Contents

Since last LHCC collaboration has made major technology choice at the VELO Upgrade Technology Review (VUTR)

- Decision made for microchannel cooled pixel technology
- Conclusions of meeting will be described in this talk

Two major upgrade bids related to LHCb VELO have been submitted:

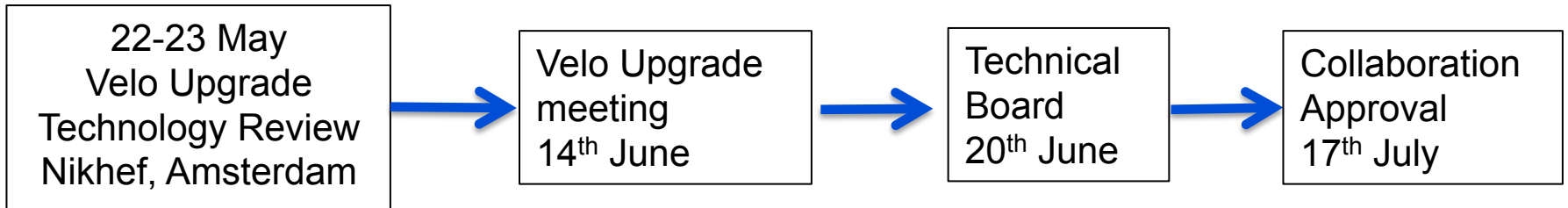
- UK: Covers RICH, VELO, physics+computing (+SciFi)
- Netherlands: Covers VELO, SciFi, HLT

VELO TDR planned for end of year, supported by important system electronics review on November 7<sup>th</sup>

A few highlights from developments since the VUTR will be described in this talk

- Microchannel cooling developments
- News from the Pixel ASIC
- Sensor Development

# VELO Review Process



## Supporting Documentation (Internal LHCb documents)

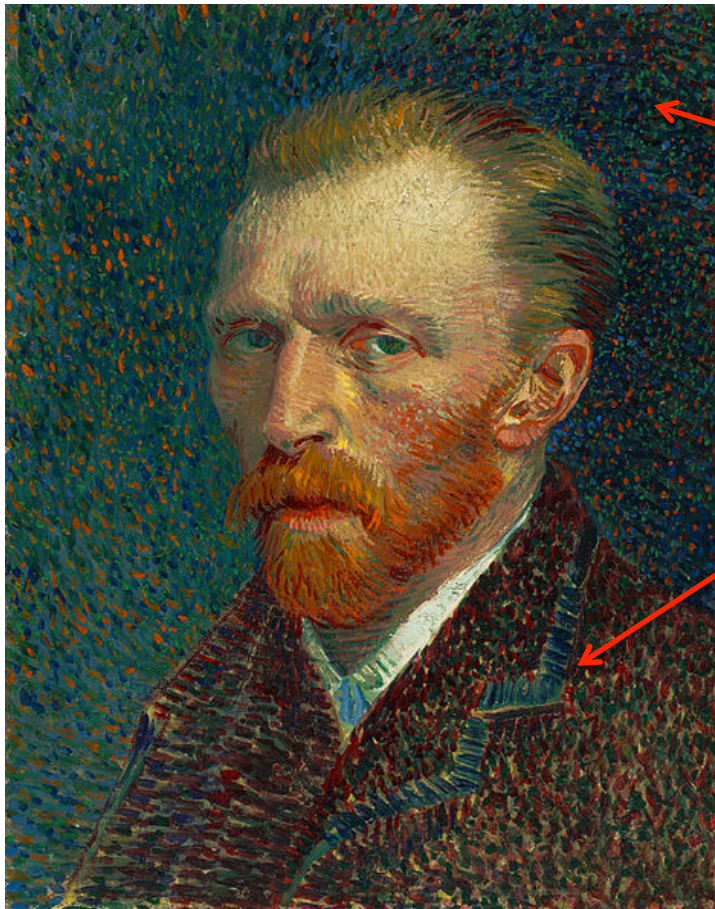
VELO Upgrade Technology Review Support Document  
UPT (Upgrade, Physics and Trigger) Document  
Referee Report  
Group statements and Group Leader Statements

## Many thanks to referees:

Richard Brenner, Hans-Juergen Hilke, Petra Riedler, Thomas Ruf and Andrea Venturi.

# VELO Upgrade Technology Review

Amsterdam 22-23 May 2013



Segmentation:

Pixels

or

Short Strips

Which gives the better definition?

# Scope of Review

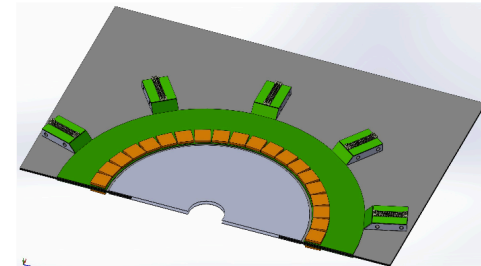
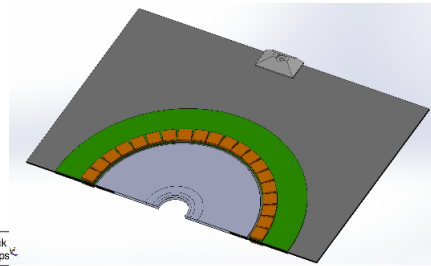
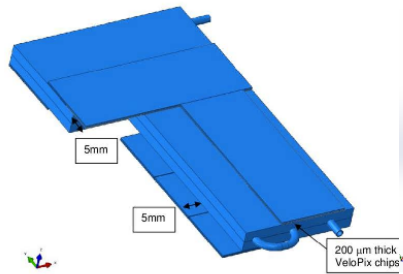
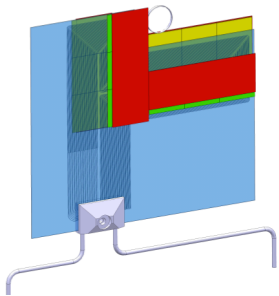
## Consider viability of four specific scenarios

Pixel sensors,  
microchannel cooling

Pixel sensors,  
pocofoam cooling

Strip sensors,  
microchannel cooling

Strip sensors,  
TPG block cooling



All options have equivalent foil thickness and clearance, same minimum radius, full geometric efficiency etc.

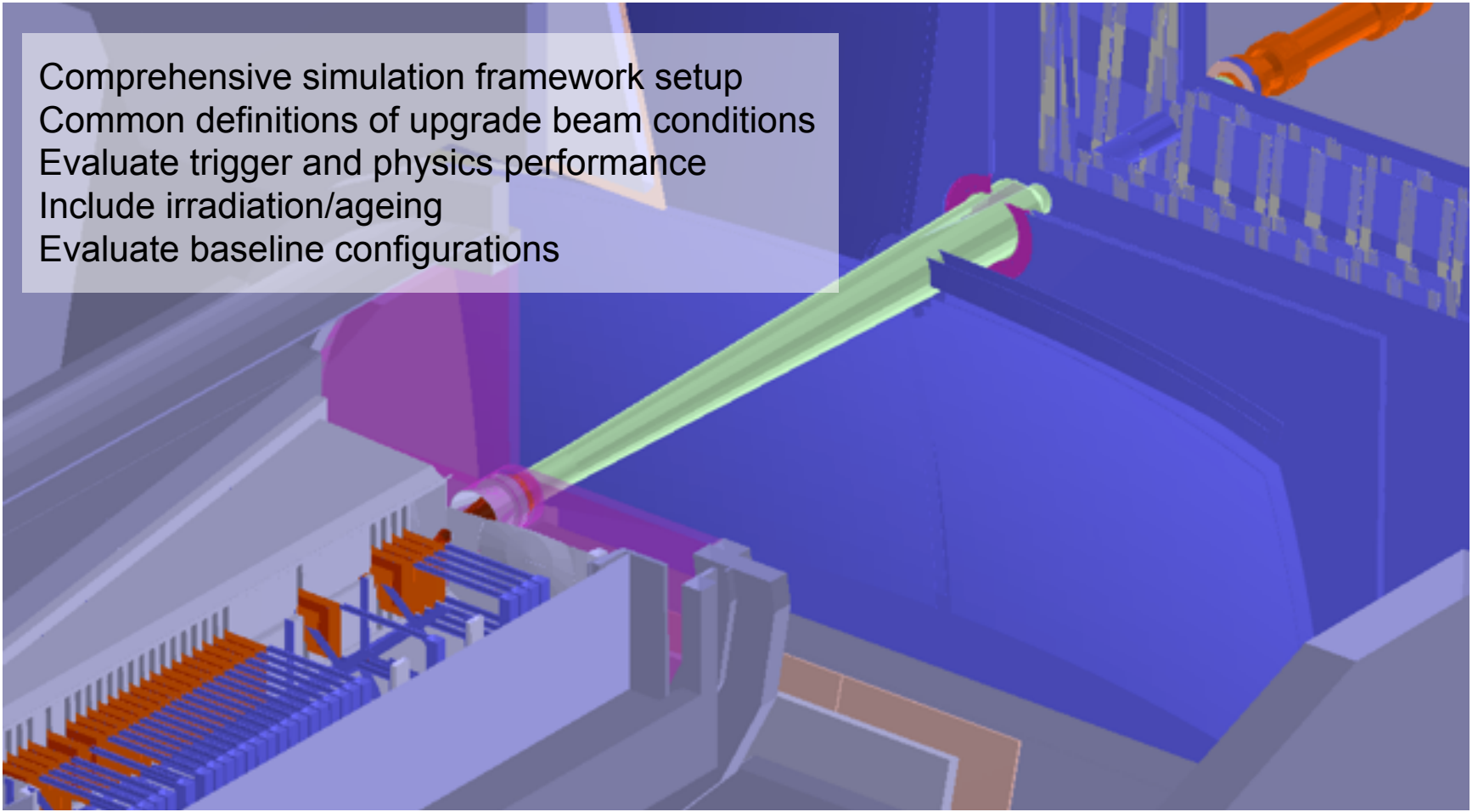
All options have integrated cooling (departure from current VELO)

Focus on system aspects which are affected by technology choice

**Reviewer mandate:** Review “fairness” of comparisons, identify missing items, identify risks, highlight pros and cons of sensor technology and cooling technology

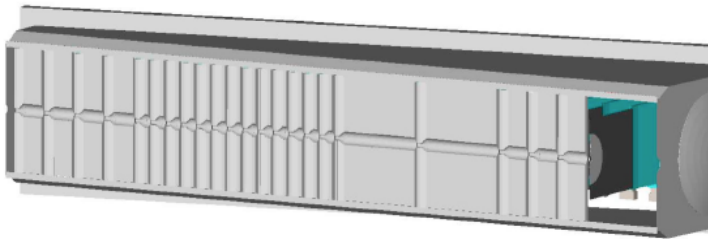
# Upgrade Simulation

Comprehensive simulation framework setup  
Common definitions of upgrade beam conditions  
Evaluate trigger and physics performance  
Include irradiation/ageing  
Evaluate baseline configurations

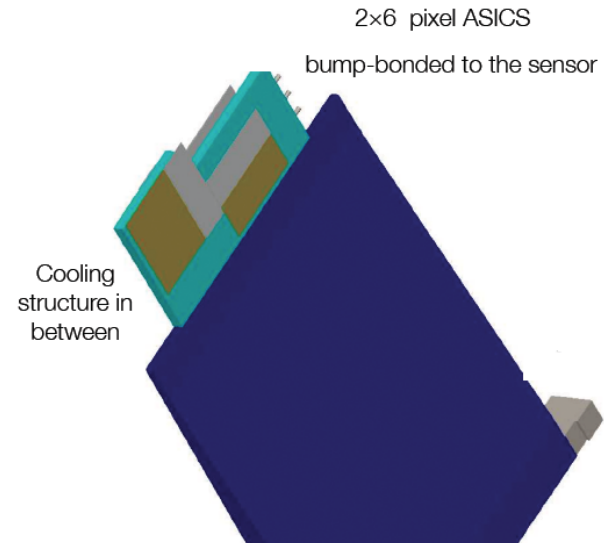
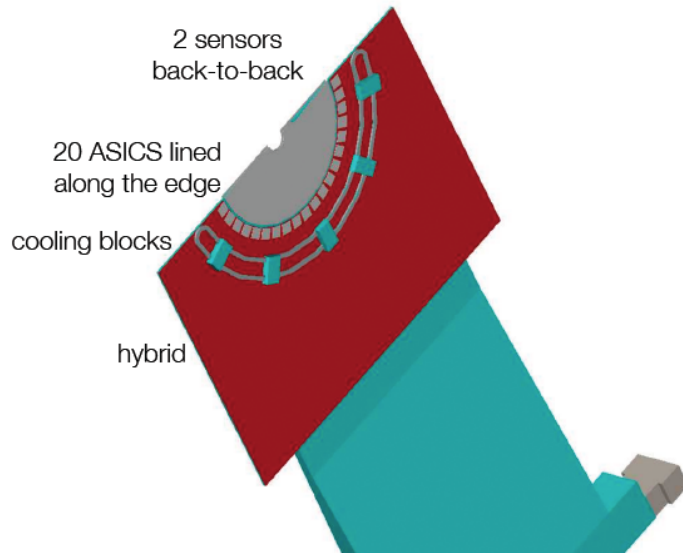
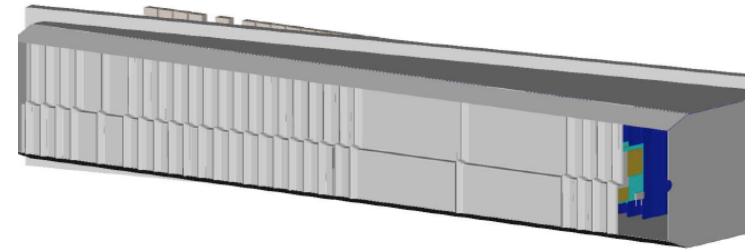


# Pixel/Strip module concepts

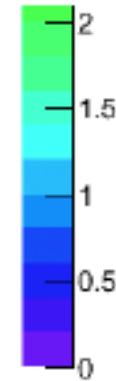
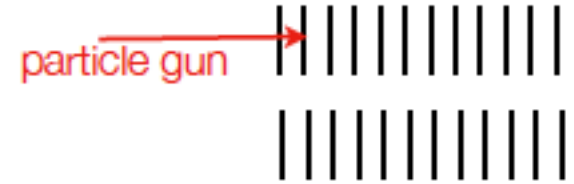
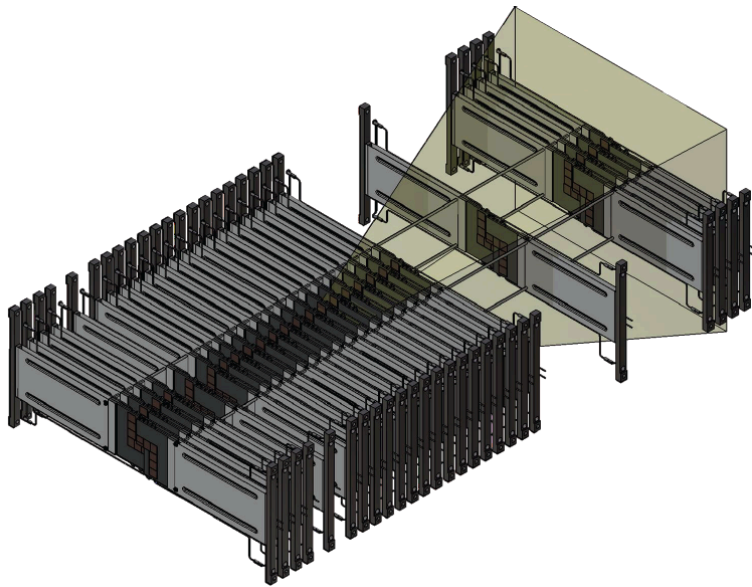
Strip modules, U shape foil



Pixel modules, L shape foil



# Material budget



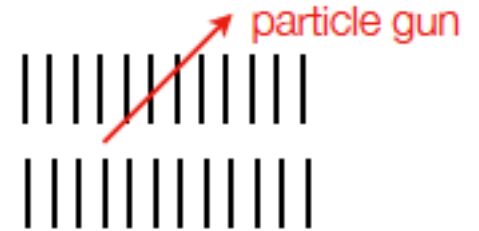
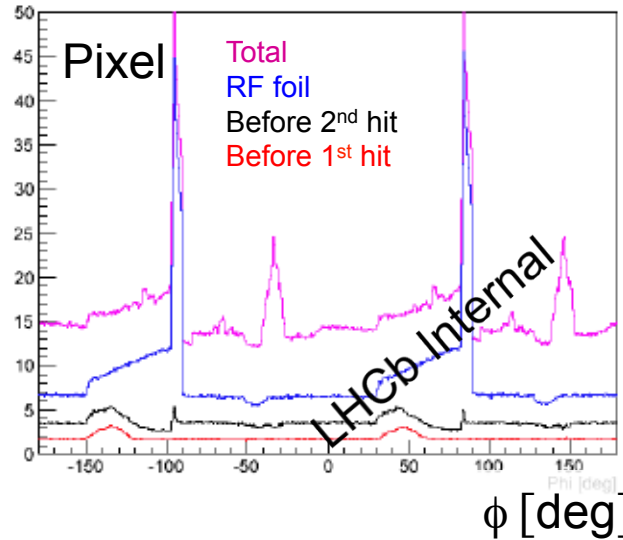
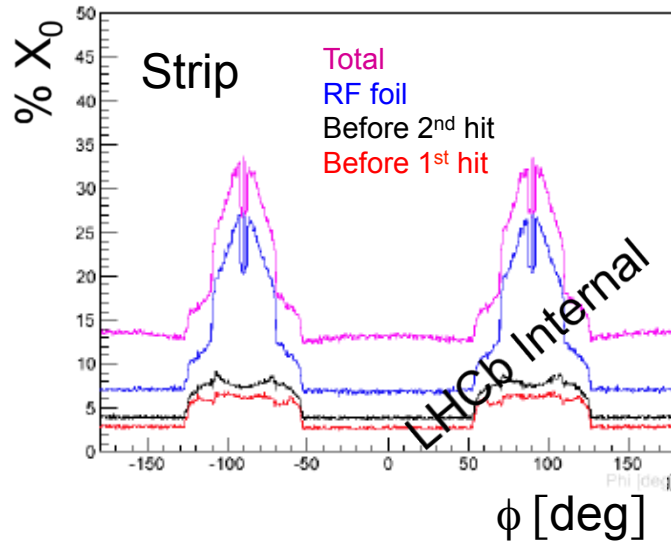
Innermost module material, particle gun

All VELO module material is in the acceptance  
Strong dependence on angle and z origin  
Strip modules have slightly lower material budget



# Material Budget

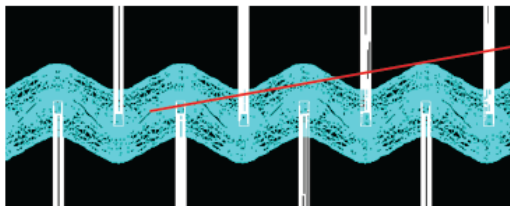
Material budget seen by particles produced in proton proton collisions in LHCb



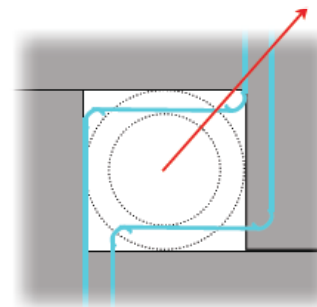
Total amount of material similar between strip/pixel

Pixels have less material before 1<sup>st</sup> measured point

1<sup>st</sup> measured point in the pixels is slightly further away

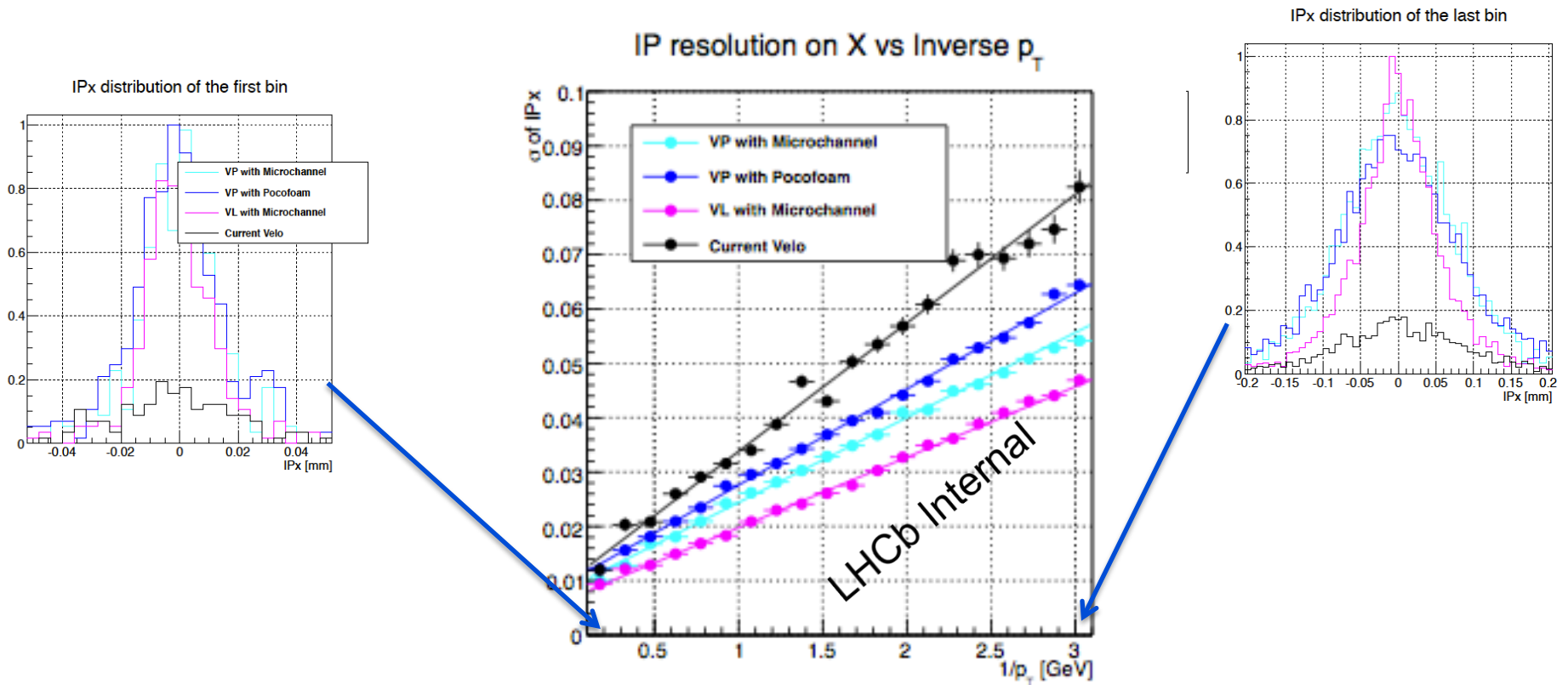


Tracks with large azimuthal angle see more material from the overlapping foils



L shaped foil breaks the radial symmetry. Tracks traverse high  $X_0$  region more acutely

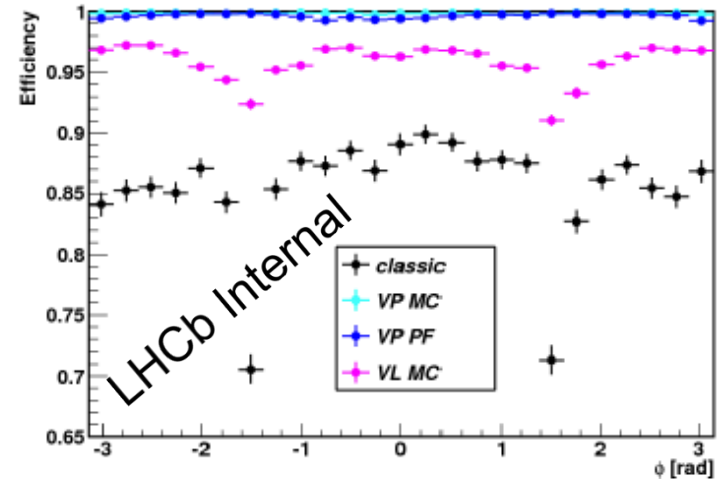
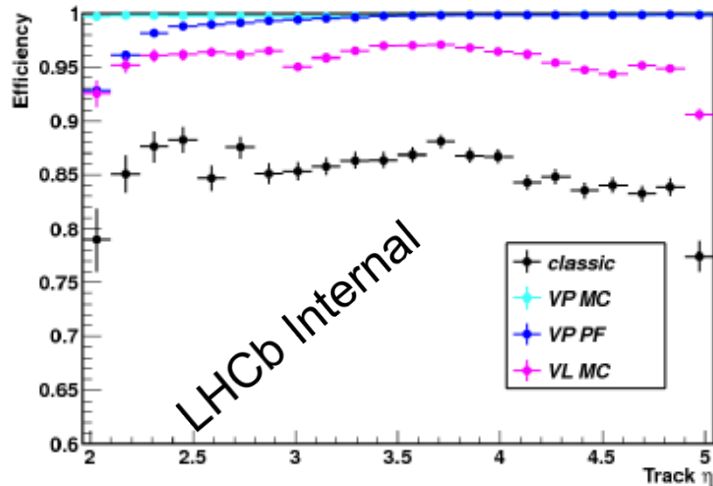
# Simulation: Impact Parameter



All options better than current VELO, in upgrade conditions  
Excellent pixel performance reflects in part advantages of L shape design  
phi dependence for both strips and pixels

# Tracking Efficiency and Timing

## VELO reconstruction efficiency: Upgrade conditions



All options superior to current VELO, in upgrade conditions

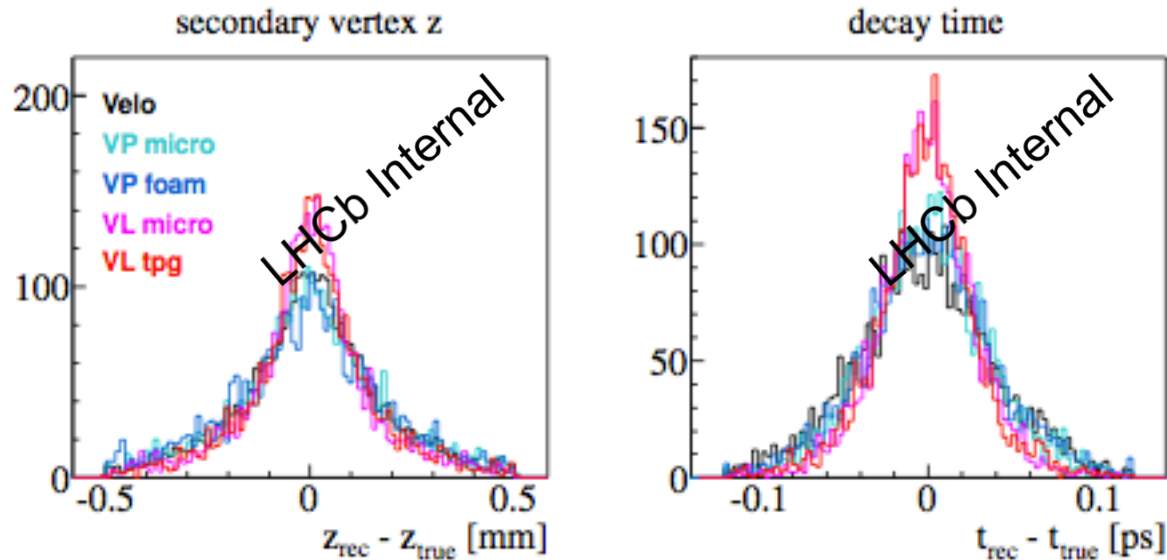
Pixel option uniformly close to 100%

Strip option ~ 96%

VELO pixel timing faster (with caveat that clustering must be added at <2 ms)

Setup	Time [ms/evt]
Velo classic $\nu = 3.8$	< 2
Velo classic $\nu = 7.6$	4.8
VL TPG $\nu = 7.6$	8.7
VL $\mu$ Ch $\nu = 7.6$	7.5
VP pocofoam $\nu = 7.6$	3.6
VP $\mu$ Ch $\nu = 7.6$	2.8

# Decay Time Resolution



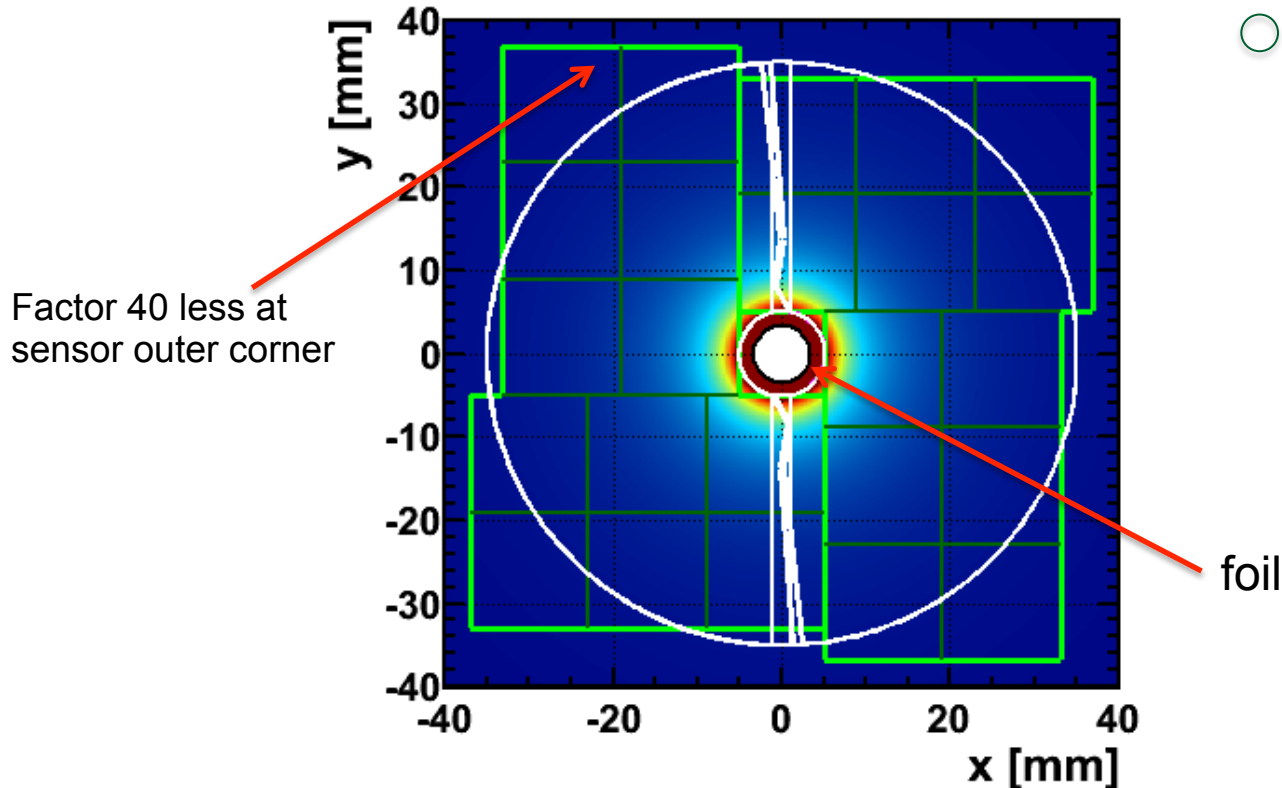
20-30% advantage for strips – for time dependent analyses  
Translates (via dilution) to a ~15% statistical advantage  
This must be weighed against the tracking efficiency

We note that other resolution dependent effects remain unquantified  
Hence we cannot relax the pressure on material reduction in modules and foil

# Radiation Damage

Common problem to either solution

Highly non-uniform radiation damage of up to  $8 \times 10^{15} n_{eq}/cm^2$  for  $50 fb^{-1}$



Equivalent to full lifetime super-LHC

Strip (white) and pixel (green) layouts superposed above anticipated flux (arbitrary scale)

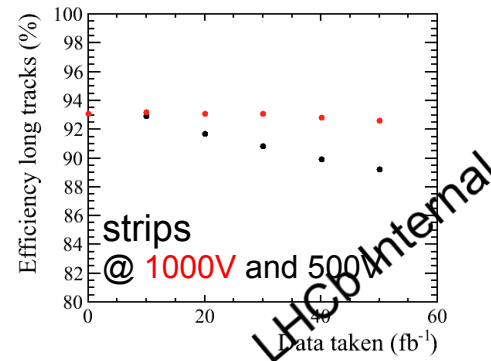
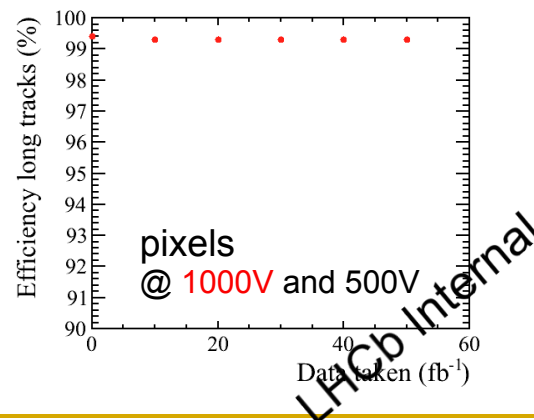
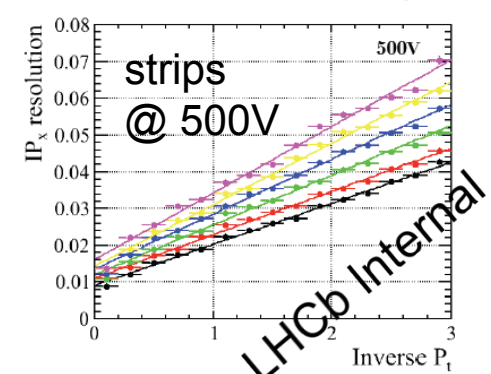
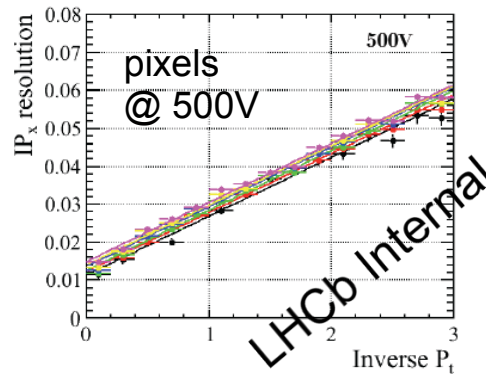
# Radiation Damage

Assessed with a simple module of depth dependent charge collection  
Model is pessimistic in some aspects, optimistic in others

At 1000V both solutions  
stable over full lifetime

At 500V changes seen  
for strip case

Difference driven by the S/N  
of each option



# Referee Report – Key Points

- No real show stopper identified for any solution!
- Physics performance perceived to be rather equivalent -> Don't focus on it now, but optimise, optimise, optimise, once the choice is taken
- Sensor prototyping and radiation hardness programme encouraged
- RF foil is critical in either option and further efforts to optimise and thin the design are encouraged with high priority
- Risk assessment for microchannel necessary
- ASIC development schedule highlighted as critical (incorporating possible second submission and serialiser MPW), detailed suggestions for design.
- Schedule is tight

# VELO Group Leader meeting





# Collaboration Endorsement

**VELO Upgrade group recommendation:**

**The collaboration adopts the pixel module with microchannel cooling as the baseline solution. This recommendation endorsed by all institutes.**

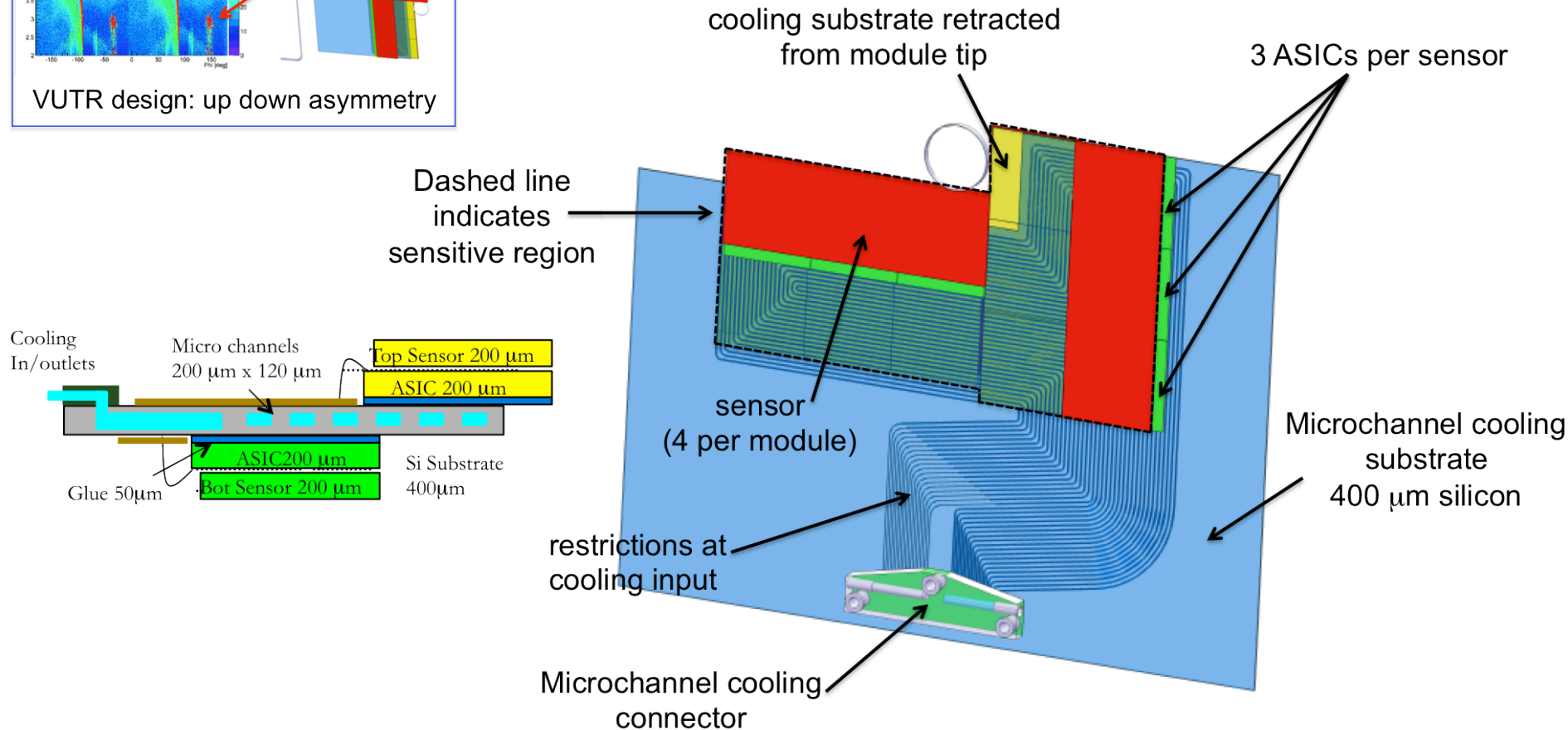
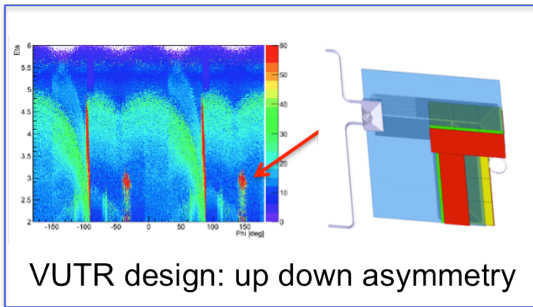
**Collaboration endorsement July 17<sup>th</sup> 2013.**

**Recommendations of referees highlighted in following slides.**

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# Highlights since VUTR

# Pixel module layout and modifications



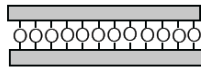
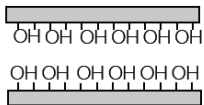
# Microchannel cooling: Endurance

Expect operational pressures of ~15 Bar, and ~60 Bar at room temperature  
Including safety limits, must withstand > 150 bar

Possible to provoke breakage in early prototypes with large outlet manifolds  
Hydrophilic and Hydrophobic bonded samples broke in different ways, with hydrophobic samples being much stronger

## “Hydrophilic” bonding

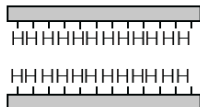
- water molecules coat the surface
- Gives an good quality, even bond



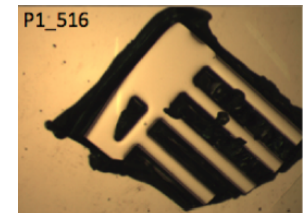
Hydrophilic breakage:  
laterally across bond layer



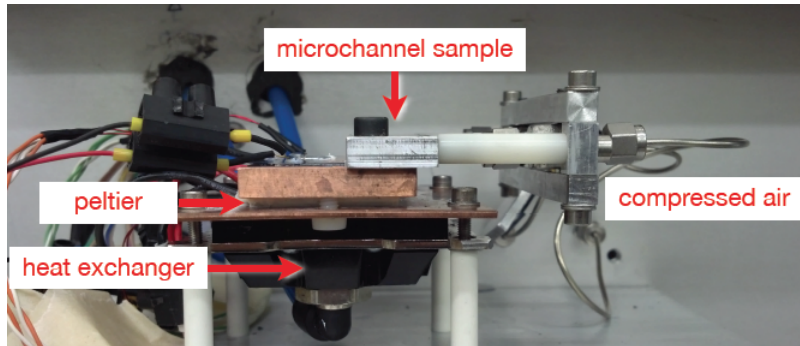
## “Hydrophobic” bonding



Hydrophobic breakage:  
within silicon crystal



# Microchannel cooling: Endurance



Automated cycling of temperature and pressure to most extreme values and with numerous repetitions

Measurement complicated by moisture in dry air blocking channels

## Measurement history

High Pressure (100-200 bars) and temperature cycles

- Partially/completely blocked at low temperatures (ice making)

Only high pressure cycles (room temperature)

- No problems!

Temperature and high pressure cycles with dry air

- occasional blockages at low temperatures ( $< 0^{\circ}\text{C}$ )

Temperature cycles at constant low pressure (3,12 bars)

- Sample got blocked while raising pressure at low temperature

Temperature and pressure cycles only when  $T > 0^{\circ}\text{C}$

- No problems so far (12 bars, next step: 70 bars)

## Measurement summary

Hydrophobic samples do not break up to 700 bar

Most temperature cycles: 1184 @ 12 bar  
 $-38^{\circ}\text{C}$  up to  $42^{\circ}\text{C}$  ( $\Delta T \sim 80^{\circ}\text{C}$ )

Most pressure cycles: 1000 @  $21^{\circ}\text{C}$   
 $\Delta P \sim 143$  bar

Next step: temperature cycles at high pressure

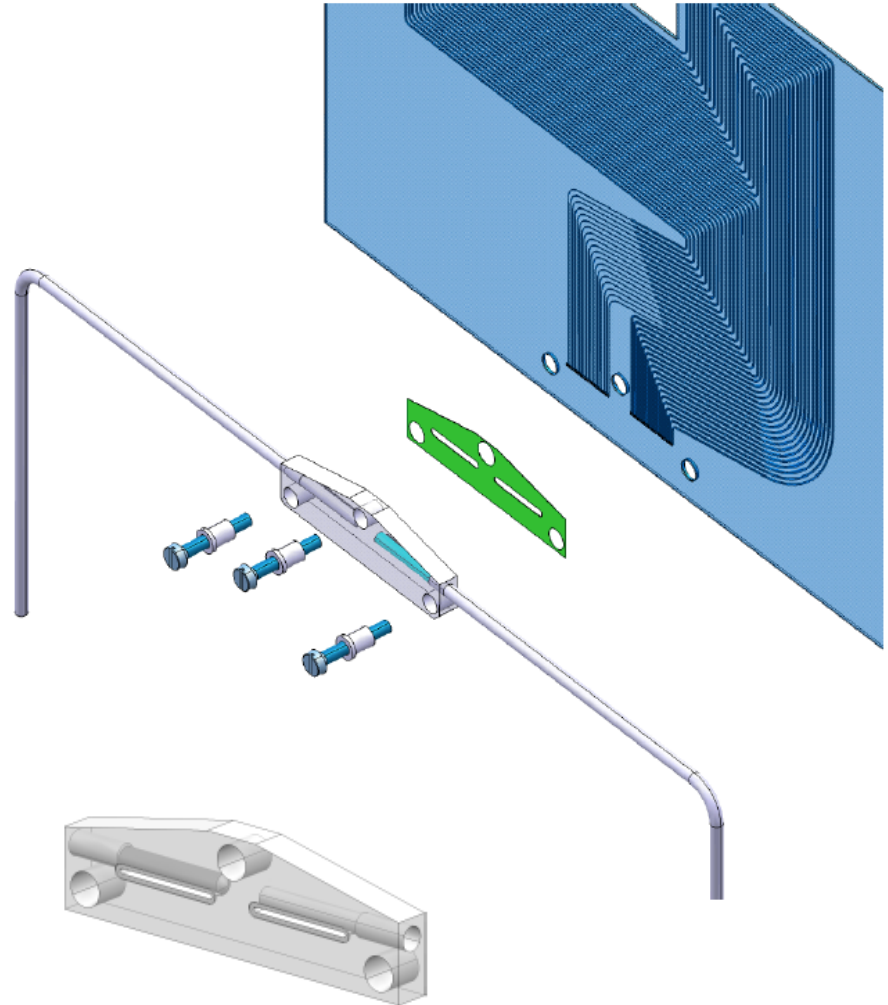
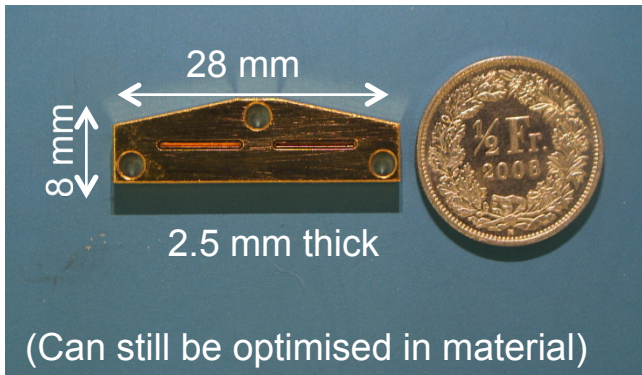
# Microchannel cooling: Connectors

## New fluidic connector design

500  $\mu\text{m}$  diameter inlet hole replaced by 7000 x 200  $\mu\text{m}$  long slid

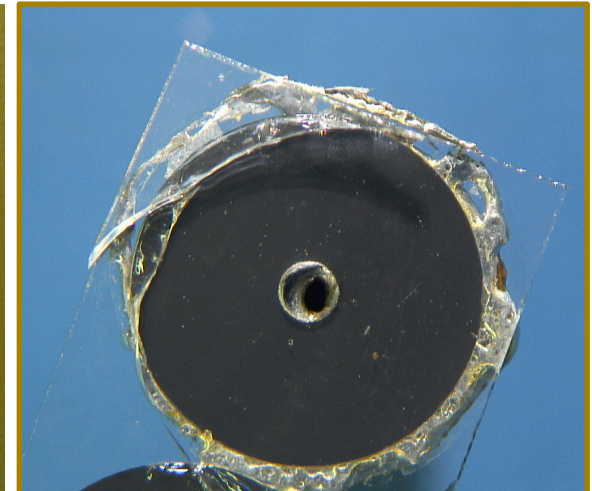
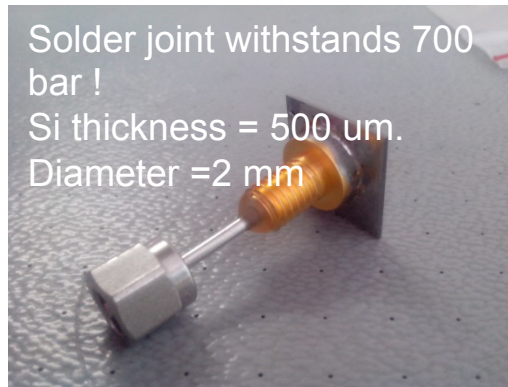
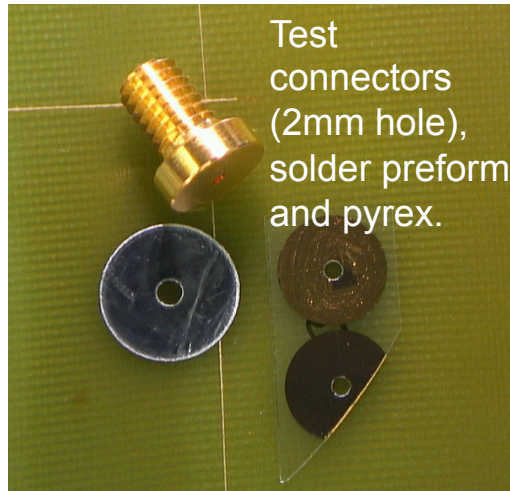
Less pressure drop

More pressure safety (smaller critical dimension)



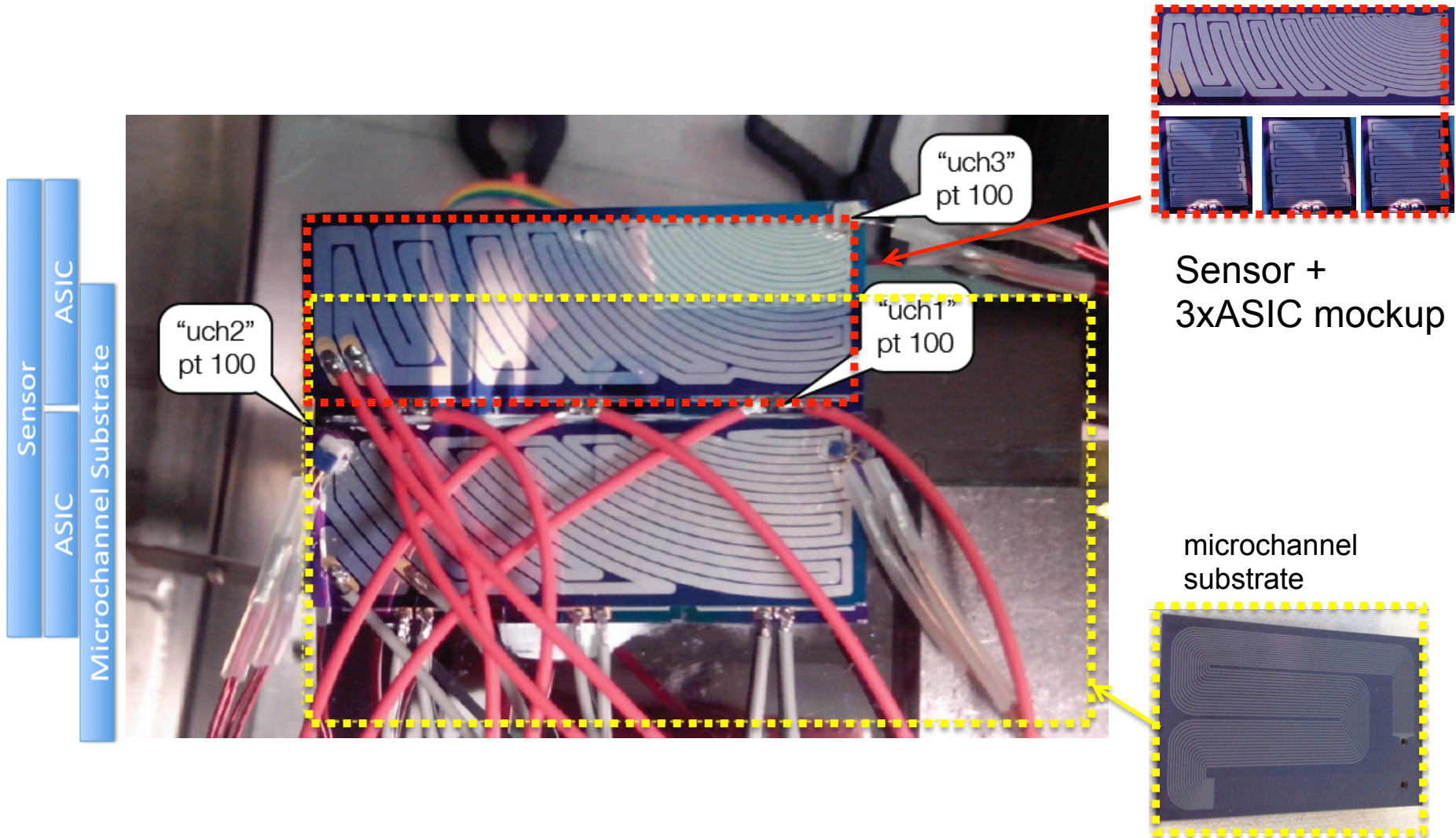
# Microchannel cooling: Connector attachment

- Soldering trials done with test connectors and pyrex (500um).
- Solder test on new iron connector and Pyrex will be done this week.
- Later, Covar connectors will be soldered on Si samples.
- Then extensive stress testing (temperature & pressure cycling).
- Production of a full size microchannel layout in Si-Pyrex has started at EPFL.



Test connectors soldered on pyrex. Allows to view how the solder has flowed. (Pyrex has cracked along the periphery due to CTE mismatch. No delamination on solder joint!)

# Microchannel cooling: Performance





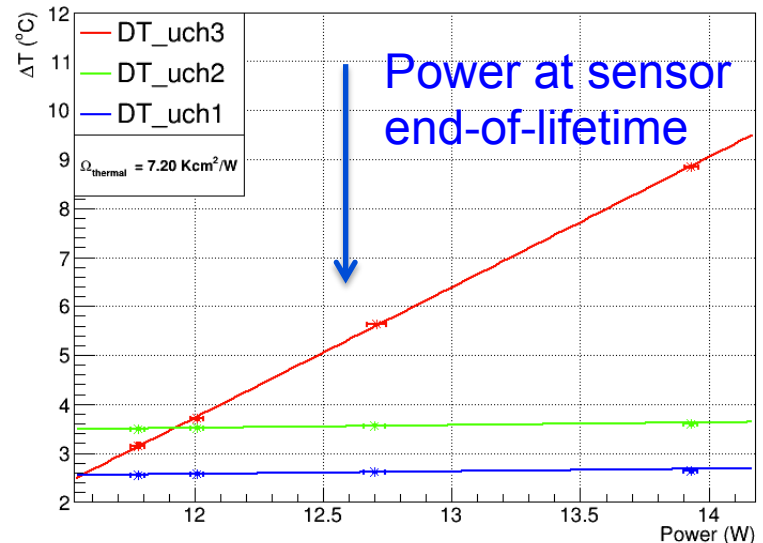
# Microchannel cooling: Performance

Results of tests on 1/2 scale mockup

ASICS operated at full power

Sensor power gradually increased

Red curve:  $\Delta T$  at sensor tip  
(allowed  $\Delta T < 15^\circ\text{C}$ )



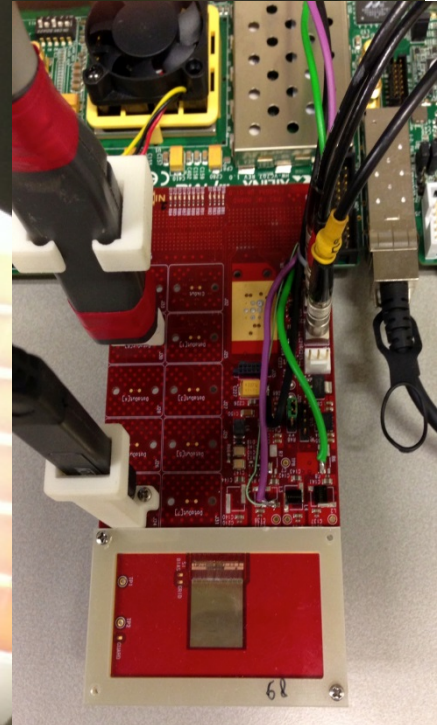
Based on this experience, the following changes made to the design:

- ❑ 200x120 $\mu\text{m}^2$  channels (was 200x70 $\mu\text{m}^2$ ) – reduce flow resistance
- ❑ 60x60 $\mu\text{m}^2$  restrictions (was 30x70 $\mu\text{m}^2$ ) – reduced risk of clogging
- ❑ 500  $\mu\text{m}$  channel spacing (was 200 $\mu\text{m}$ ) – reduced number of channels

# Timepix3\*

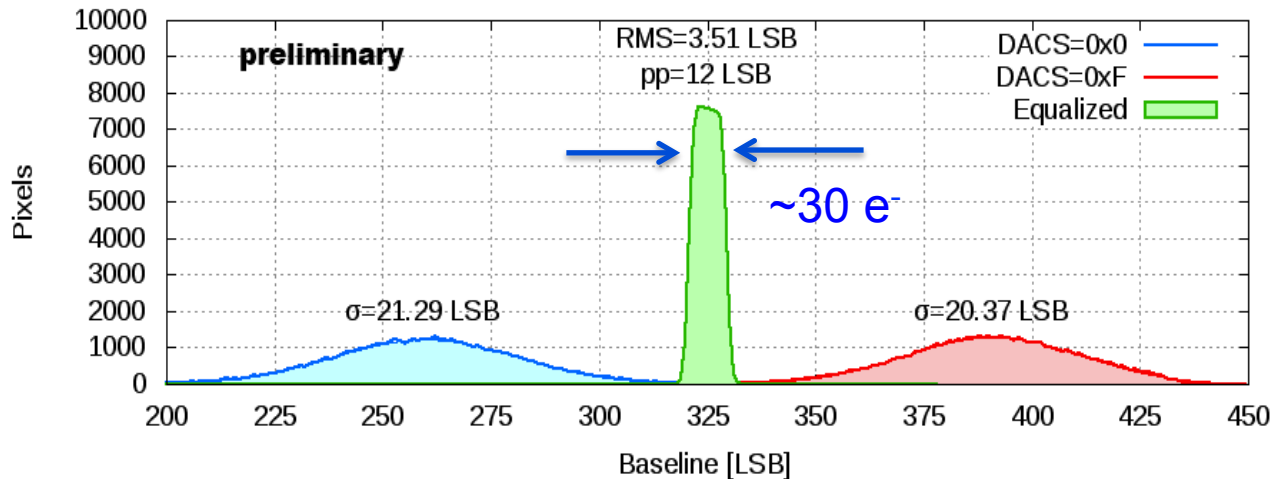
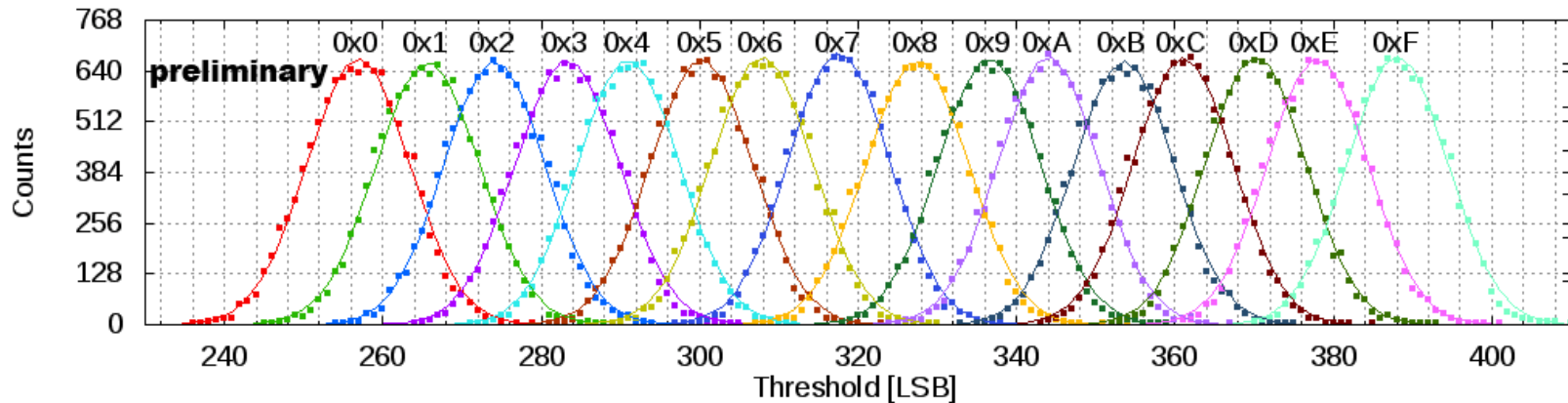
- 6 wafers received in August.
- 1 wafer diced.
- 2 ASICS under test at CERN and NIKHEF.
- Periphery and pixel matrix are fully functional. No problems detected so far.
- Serial output links running at 640 MHz
- Pixel noise is very low:  $\sim 65 e^-$  (preliminary).
- Threshold mismatch after equalization is excellent:  $\sim 30 e^-$  (preliminary).
- Power consumption as expected 450mA (analog), 370mA (digital, 'no hits')

Timepix3 is a 'precursor' of Velopix.  
Same design & test team and environment  
**VERY ENCOURAGING** step towards VELOPIX



\* Designed in the context of the Medipix3 Collaboration by CERN, NIKHEF, Univ. Bonn

# Timepix3 - Highlights

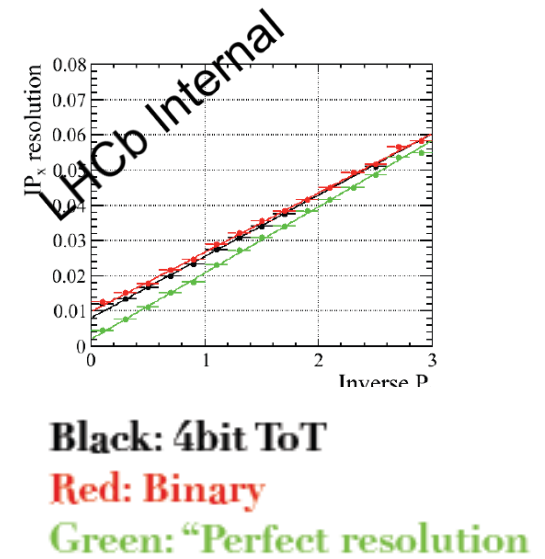


- Equalisation fully functional
- gain to be confirmed
- Calibration DAC: excellent linearity
- **More results to come!**
  - TWEPP, IEEE-NSS

S. Kulis, CERN-LCD

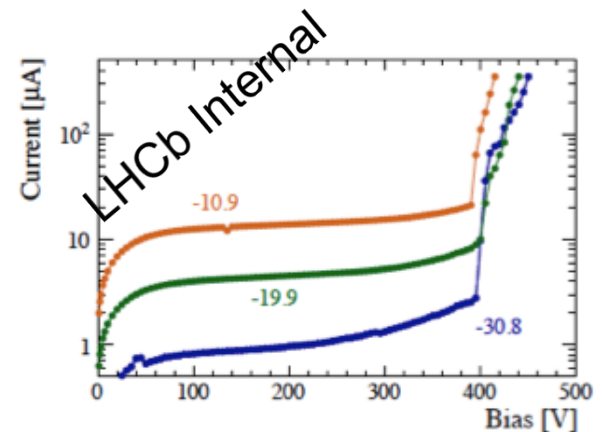
# Binary versus ToT read-out

- Binary read-out has advantages over ToT for the chip design
  - 2x4 super-pixels are preferred
    - ToT very tight fit
  - Binary simplifies logic in ASIC (and TELL40)
    - fixed packet length format
    - Also reduced data size
    - Allows faster discharge of front-end, reducing dead-time
- ToT advantages
  - Better resolution (marginally)
  - Front-end characterisation
  - Avoids threshold scans
  - In particular during beam time
  - Extra physics information; converted  $\gamma$ ,  $dE/dx$ ...
- Decision end of this week

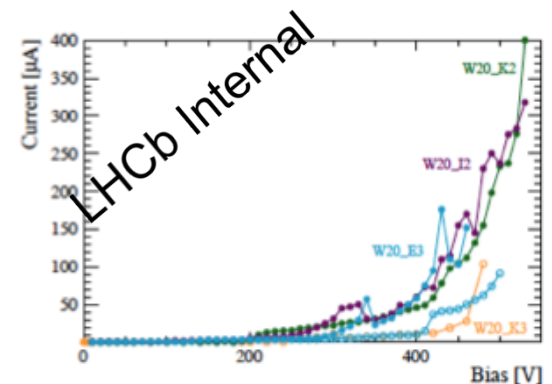


# Sensor & bump-bonding prototyping

- August Workshop to plan the prototyping & testing
  - TimePix(3), sensors, bump-bonding
- Main issues concerning the sensors
  - HV tolerance (guard ring design)
  - Thickness (bump-bonding yield)
- Reduce phase-space in prototyping
  - 200  $\mu\text{m}$  thickness (both for sensor & ASIC)
  - 450  $\mu\text{m}$  guard ring + conservative option
  - n or p type: discuss with vendors
- Test programme
  - Irradiations (3 fluences)
  - Lab tests (I/V, source, ...)
  - Beam test (DESY Feb. 2014, TimePix3)



Post irradiation IV curves  
of 100  $\mu\text{m}$  n-in-p VTT  
edgeless Medipix assemblies



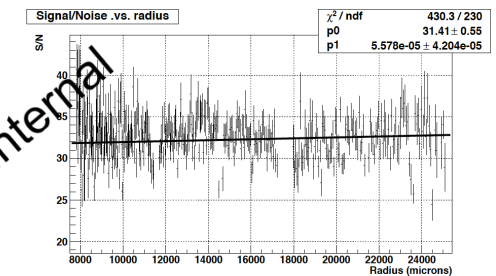
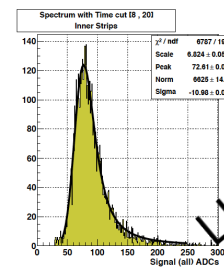
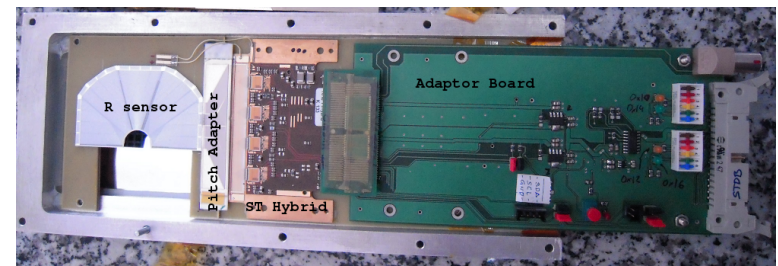
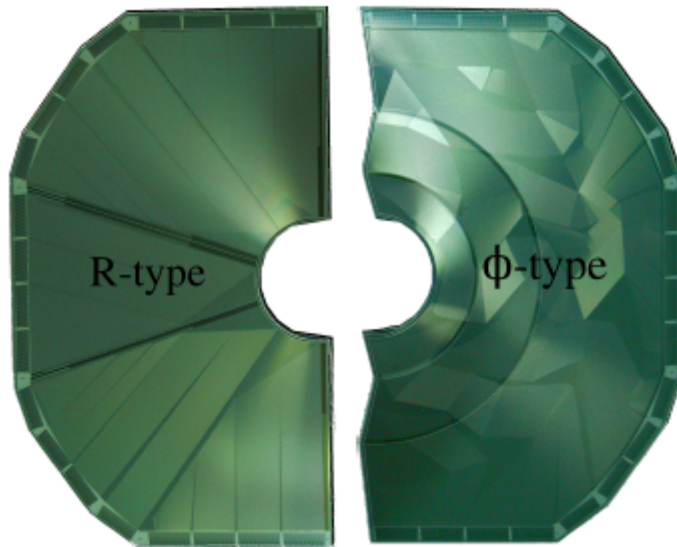
pre-irradiation IV curves  
Micron assemblies with  
and without paralyne coating

# Swan song from strip sensor R&D

Full scale (non-compact) HPK prototypes produced and assembled into module

- Full metrology and electrical characterisation satisfactory
- Excellent S/N at all radii
- Referees encouraged completion and documentation of a large body of work

Some caveats on HV, but 800V achieved



# Conclusions

VELO Upgrade is progressing rapidly

Detector will be built with microchannel cooled pixel modules

- very encouraging progress on microchannel R&D
- Timepix3 is delivered and showing very promising results

Funding requests are in the pipeline

Schedule tight but detailed work is underway

Thank you for your attention

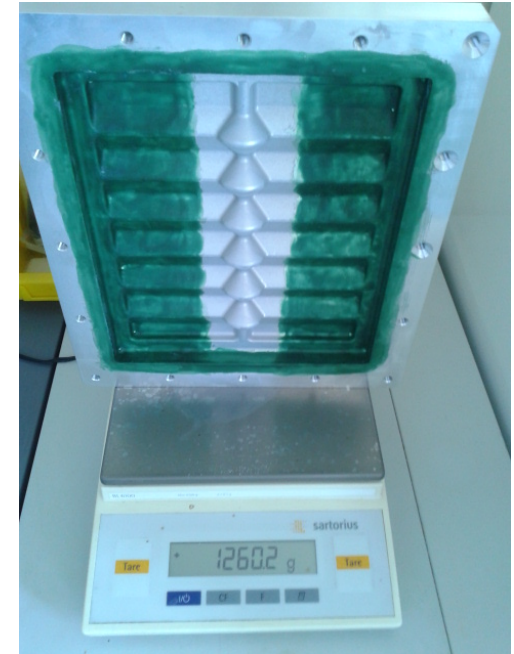
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# Backup slides



# Thinning of the RF foil

- Aim: develop a method to thin down RF foil
  - machining unlikely to reach 100  $\mu\text{m}$
- Use chemical etching (NaOH)
- Four prototype foil samples produced
- Procedure:
  - metrology (thickness map)
  - vacuum leak test
  - etch
  - vacuum leak test
  - metrology (confirm thickness control)
- First tests promising
  - first results before end Sep



thanks to: EN-MME and TS VSC colleagues for support in this R&D

# VL vs VP (microchannel) – common understanding

**Tracking efficiency** – Advantage pixels! (by 4-5%)

**IP resolution** – Advantage strips! (slender advantage)

**Ghosts** – not an important factor from HLT viewpoint

**Timing** – Advantage pixels! (but not so dramatic)

**Radiation Damage** – Advantage pixels!

**Systematic uncertainties** - let

**RF box** - let

**Risk (sensors)** – Advantage pixels!

**Risk (modules)** – level (experience is with strips)

**Risk (ASICs)** – No showstopper! (not assessed for strips)

Game, Set and Match...?